

IFW



Docket No.: 071971-0015

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 53080
Shiro SAKIYAMA, et al.	:	Confirmation Number: 6689
Application No.: 10/511,165	:	Group Art Unit: 2816
Filed: October 14, 2004	:	Examiner: HILTUNEN, THOMAS J
For: SEMICONDUCTOR INTEGRATED CIRCUIT	:	

SUBSTANCE OF INTERVIEW

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

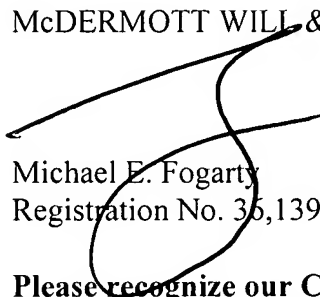
This Substance of Interview is submitted in response to a Personal Interview on August 13, 2007. Examiner Thomas Hiltunen, Primary Examiner Kenneth Wells, and Applicant's Attorney Ed Garcia-Otero were present. The prior art of record (Tang, Kaenel, Forbes, and Bowden) was discussed. New prior art Shoji (U.S. Patent 4,670,670) was also discussed. Examiner Hiltunen stated that FIG. 7D of the application combined with FIG. 5. of the application may be allowable subject matter. Examiner Hiltunen stated that he would write an Office Action in response to the Request for Continued Examination filed June 7, 2007.

Application No.: 10/511,165

Applicants submit that no fees are required at this time. However, please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

Respectfully submitted,

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